

Application No. 10/586,445
Amdt. dated 18 November 2010
Reply to Office Action of 19 August 2010

Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims:

Claims 1-7 Cancelled

8. (new) A method for predicting a precipitation behavior of oxygen in a silicon single crystal for predicting behavior of oxygen precipitates produced in the silicon single crystal in response to heat treatment, comprising:

dividing a heat treatment process into a plurality of time segments;

determining a nucleation rate $I(T, C, TD)$ of the oxygen precipitates in each time segment from a nucleation rate formula,

$$I(T, C, TD) = a(T) C^9 TD^{1/3}$$

wherein $I(T, C, TD)$ is the nucleation rate ($\text{cm}^{-3} \text{s}^{-1}$), C is an oxygen concentration ($\times 10^{17} \text{cm}^{-3}$), TD is a thermal donor concentration ($\times 10^{15} \text{cm}^{-3}$), T is a temperature; $a(T)$ is a constant determined by the temperature; and

determining a density of nuclei $N(t')$ of the oxygen precipitates produced during a period Δt that begins at the time t' , from a formula,

$$N(t') = I(T, C, TD) \Delta t.$$

9. (new) The method according to claim 8, further comprising:

determining a growth rate $R(t', t)$ in time t of nuclei of the oxygen precipitates produced during the period Δt that begins at time t' , from a formula,

$$\frac{\partial R(t', t)}{\partial t} = \frac{DV}{2R(t', t)}(C - C_i)$$

In which $C_i = C^{eq} \exp\left(\frac{V\sigma}{RkT}\right)$

wherein $R(t', t)$ is a radius in the time t of the nuclei of the oxygen precipitates produced during the period Δt that begins at time t' , and C_i is an equilibrium oxygen concentration at an interface of spherical particles with a radius R , and

determining an amount of precipitated oxygen from a formula,

$$\frac{\partial C}{\partial t} = -4\pi D \int_{t'=0}^{t'=t} N(t') R(t', t) (C - C_i) dt' .$$

10. (new) The method according to claim 8, further comprising:

determining the thermal donor concentration TD at the temperature T_2 from 400°C to 550°C which the silicon single crystal undergoes during crystal growth, from a formula,

$$TD = TD(T_2)^{eq} \{1 - \exp(-aDC(t_{12} + t))\}$$

wherein TD is the thermal donor concentration ($\times 10^{15} \text{ cm}^{-3}$), TD^{eq} is a thermal equilibrium concentration of the thermal donor concentration, a is a coefficient ($= 9.0 \times 10^{-50}$), k is a Boltzmann's constant, D is a diffusion constant of oxygen, C is the oxygen concentration, t is the time, and t_{12} is an equivalent time required for generation at the constant temperature T_2 of an amount of thermal donors generated during cooling to the temperature T_2 .

11. (new) A storage medium for storing a program for predicting by a computer a behavior of oxygen precipitates produced in a silicon single crystal in response to heat treatment, wherein the storage medium stores the following processing as the program:

processing in which

a heat treatment process is divided into a plurality of time segments, and

a nucleation rate $I(T, C, TD)$ of the oxygen precipitates in each time segment is determined from a nucleation rate formula:

$$I(T, C, TD) = a(T) C^9 TD^{1/3}$$

wherein $I(T, C, TD)$ is the nucleation rate ($cm^{-3}s^{-1}$), C is an oxygen concentration ($\times 10^{17} cm^{-3}$), TD is a thermal donor concentration ($\times 10^{15} cm^{-3}$), T is a temperature: $a(T)$ is a constant determined by the temperature; and

processing in which a density of nuclei $N(t')$ of the oxygen precipitates produced during a period Δt that begins at time t' , is determined from a formula,
 $N(t') = I(T, C, TD) \Delta t$.

12. (new) The storage medium for storing a program according to claim 11, wherein the storage medium further stores the following processing as the program:

processing in which a growth rate $R(t',t)$ in time t of the nuclei of the oxygen precipitates produced during the period Δt that begins at time t' , is determined from a formula,

$$\frac{\partial R(t',t)}{\partial t} = \frac{DV}{2R(t',t)}(C - C_i)$$

$$\text{In which } C_i = C^{\text{eq}} \exp\left(\frac{V\sigma}{RkT}\right)$$

wherein $R(t',t)$ is a radius in the time t of the nuclei of the oxygen precipitates produced during the period Δt that begins at time t' , and C_i is an equilibrium oxygen concentration at an interface of spherical particles with a radius R ; and

processing in which an amount of precipitated oxygen is determined from a formula,

$$\frac{\partial C}{\partial t} = -4\pi D \int_{t'=0}^{t'=t} N(t')R(t',t)(C - C_i)dt'.$$

13. (new) The storage medium for storing a program according to claim 11, wherein the storage medium further stores the following processing as the program:

processing in which the thermal donor concentration TD at the temperature T_2 from 400°C to 550°C which the silicon single crystal undergoes during crystal growth, is determined from a formula,

$$TD = TD(T_2)^{eq} \{1 - \exp(-aDC(t_{12} + t))\}$$

wherein TD is the thermal donor concentration ($\times 10^{15} \text{ cm}^{-3}$), TD^{eq} is a thermal equilibrium concentration of the thermal donor concentration, a is a coefficient ($= 9.0 \times 10^{-50}$), k is a Boltzmann's constant, D is a diffusion constant of oxygen, C is the oxygen concentration, t is the time, and t_{12} is an equivalent time required for generation at the constant temperature T_2 of an amount of thermal donors generated during cooling to the temperature T_2 occurs.